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Docket No.: 042390.P11429

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application for:)

Ansheng Liu et al.)

Application No.: 09/881,218)

Filed: June 13, 2001)

For: METHOD AND APPARATUS FOR)
TUNING A BRAGG GRATING IN A)
SEMICONDUCTOR SUBSTRATE)

Examiner: Pritchett, Joshua L.

Art Group: 2872

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Attn: Official Draftsman
Commissioner of Patents and Trademarks
Washington, D.C. 20231

TRANSMITTAL OF FORMAL DRAWINGS


Dear Sir:

Enclosed herewith for filing in the above-identified U.S. patent application are the formal drawings, Figures 1-5 (5 sheets).

Respectfully submitted,

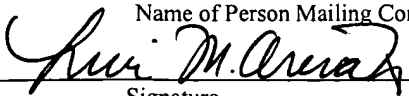
BLAKELY SOKOLOFF TAYLOR & ZAFMAN, LLP

Date: March 27, 2003


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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner for Patents, Attn. Official Draftsman, Washington, D.C. 20231

on March 27, 2003
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